

Models for Performance Analysis of Manufacturing Systems

Jacobus E. Rooda

Porto Heli (Greece)

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► Background

Levels in systems

Key performance ...

Effective Process Time

Type of models

Queueing models

Process algebra

Automata

Epilogue

References

Background

The Systems Engineering group aims to use **quantitative methods** for the analysis, design and implementation of **manufacturing** systems and **embedded** systems exhibiting **concurrent** behavior.

The objectives are to develop **theory** and **techniques**, and to build computational **tools**, inspired by **mechanical engineering science**, **computer science** and **mathematics**, and to apply these to industrial cases.

Levels in manufacturing systems

- supply chain

The subsystems are factories and warehouses.

- factory

The subsystems are areas and (groups of) machines.

- area

The subsystems are cells or individual machines.

- cell

The subsystems are groups of machines (typically scheduled as one entity).

- machine

The subsystems are machine components.

Key performance indicators

- raw (effective) process time t_0 (t_e):
The net (effective) time a system needs to process an item.
- throughput δ :
The number of items per time-unit leaving the system.
- flow time φ :
The time it takes for an item to travel through the system.
- utilization u :
The fraction of time a system is processing items.
- work in process w :
The number of items in the system.

Effective Process Time

Process time consists of

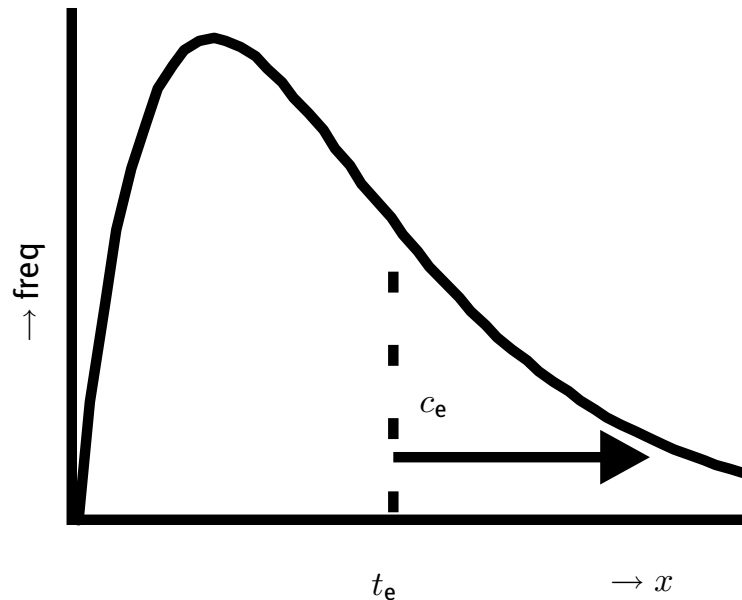
- raw (natural) process time t_0 (mean)
- variability c_0 (standard deviation / mean)

Process disturbances

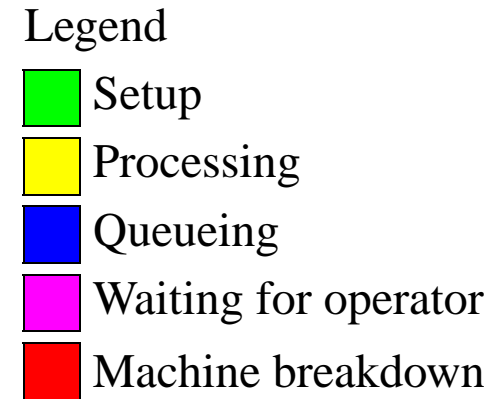
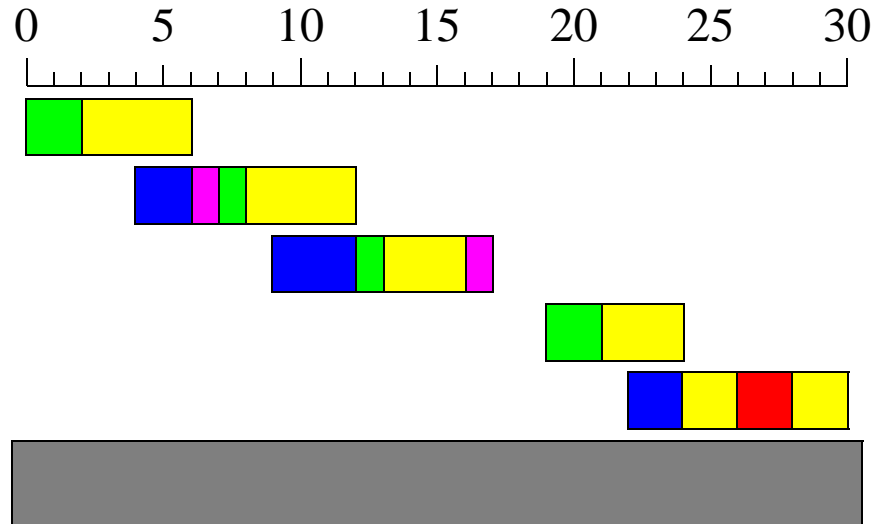
- setup times t_s and c_s
- time between failure t_f and c_f ,
- time between repair t_r and c_r
- operator delays
- rework of items
- ... (!)

The effective process time idea

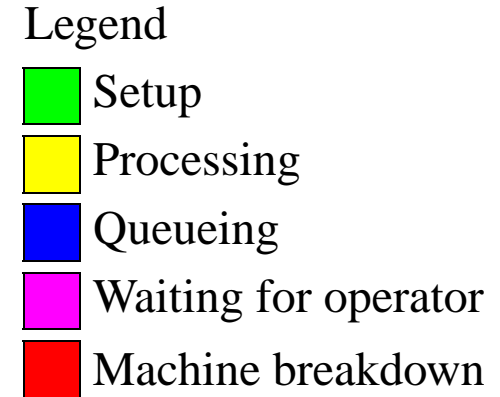
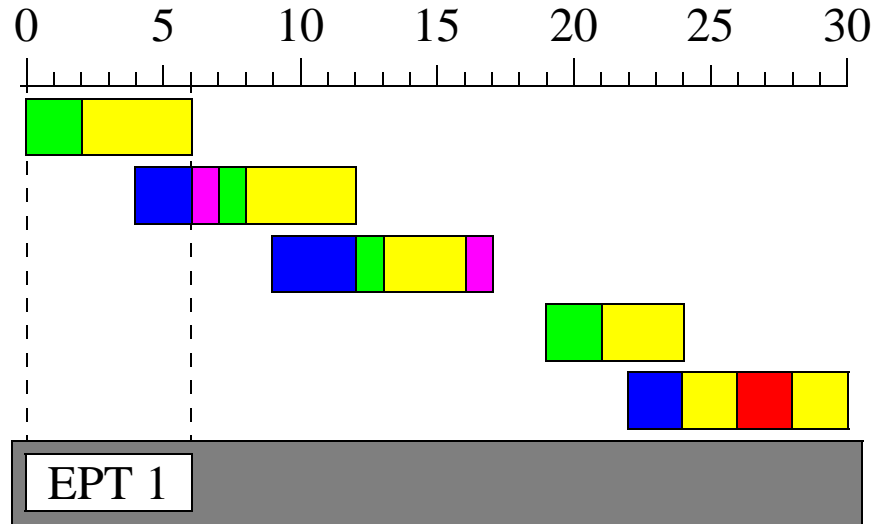
Combine all disturbances in one single EPT probability density function.



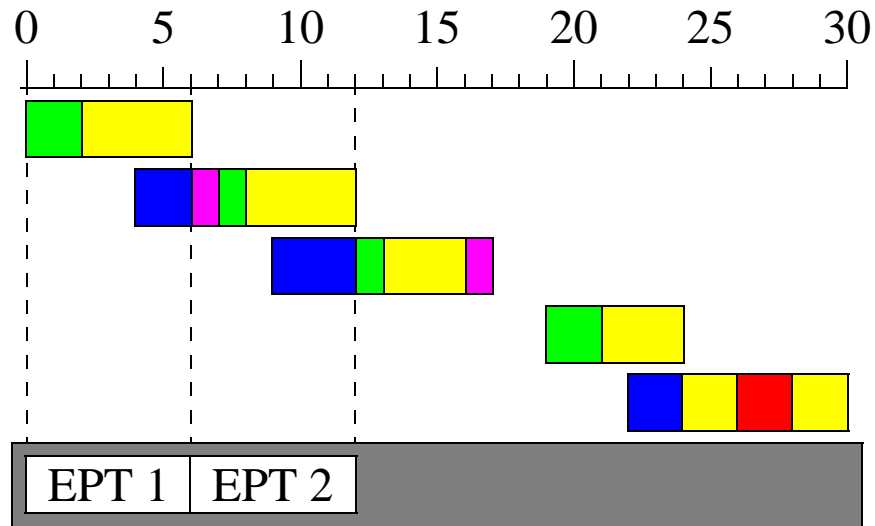
Lot-time diagram



Lot-time diagram



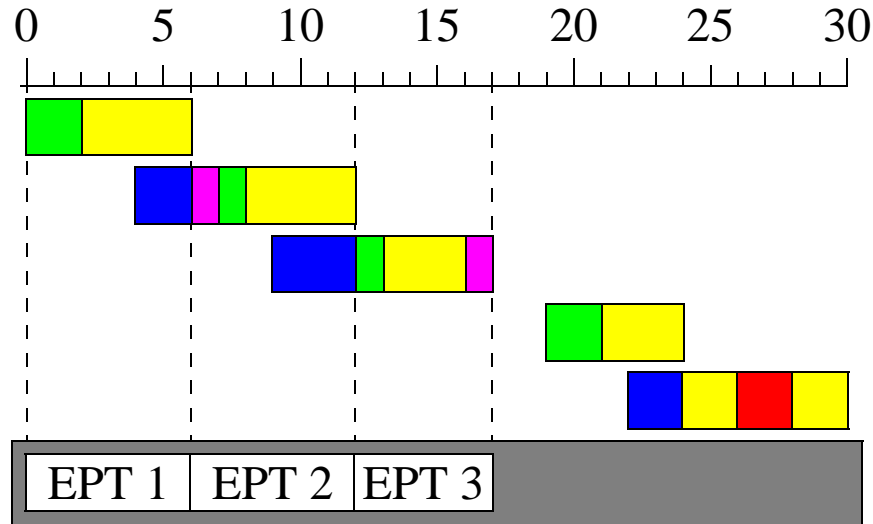
Lot-time diagram



Legend

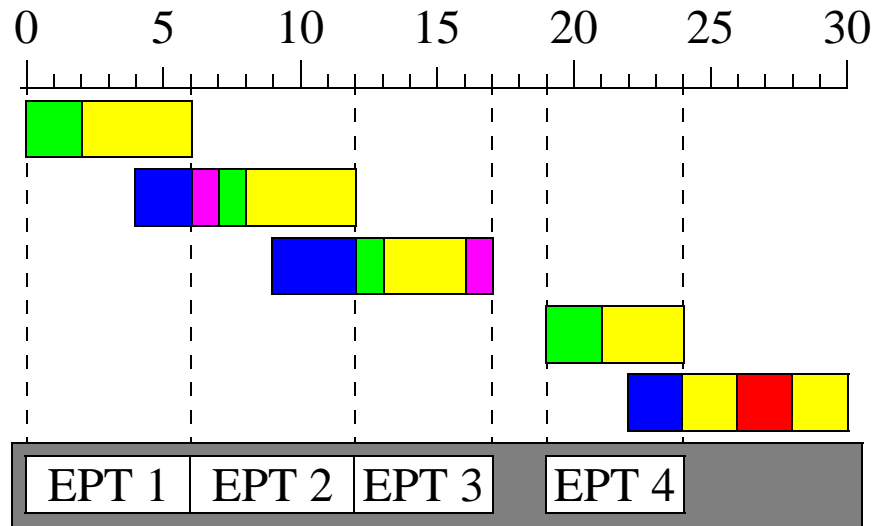
- Setup
- Processing
- Queueing
- Waiting for operator
- Machine breakdown

Lot-time diagram



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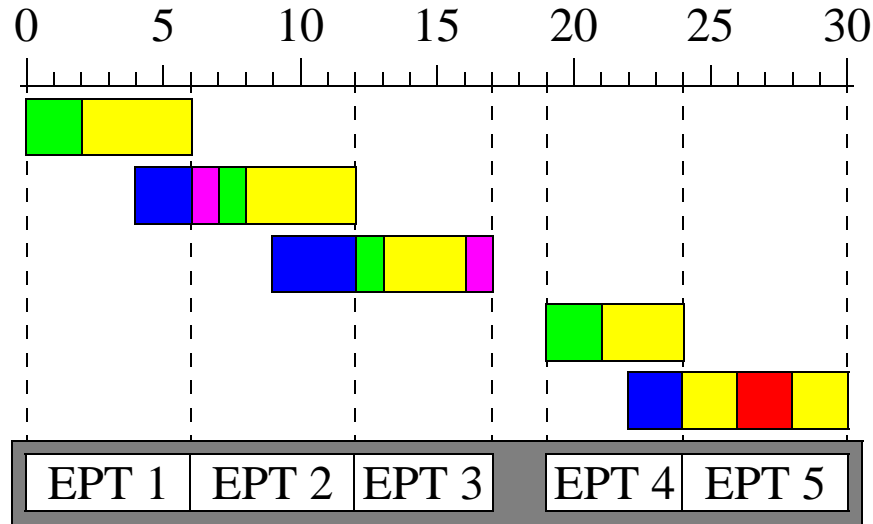
Lot-time diagram



Legend

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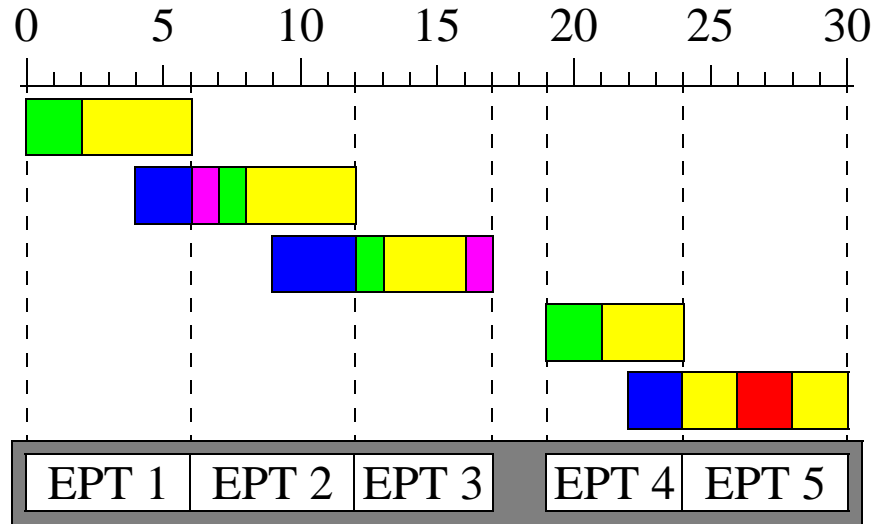
Lot-time diagram



Legend

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Lot-time diagram



Legend

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Formula (no overtake):

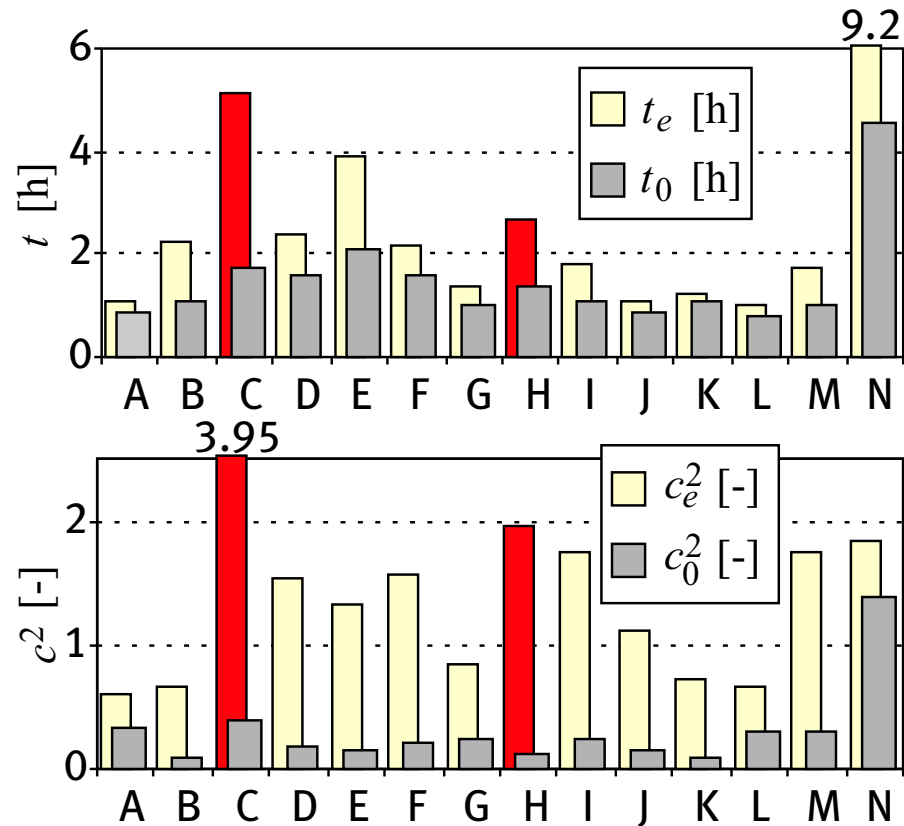
$$e_i = d_i - \max(a_i, d_{i-1})$$

Algorithm (with overtake)

- a is triggered by arrival of an item in the buffer.
- d is triggered by departure of an item (not necessarily the same one).
- C sends the value of e_i of departed item i via r to its environment.

```
proc C(chan a?, d! : void, r! : real) =  
  [[ var n : nat = 0, s : real  
  :: *( a?  
    ; (n = 0 → s := time [] n > 0 → skip)  
    ; n := n + 1  
    [] d?  
    ; r!time - s  
    ; n := n - 1  
    ; (n > 0 → s := time [] n = 0 → skip)  
  )  
  ]]
```

Case, Philips Nijmegen fabricator



Available algorithms

- Infinite buffer and one machine (previous case)
- Infinite buffer and more (equal) machines
- Finite buffer and one machine
- Finite buffer and more (equal) machines
- Batch machines (e.g. furnaces)
- Cascade machines (e.g. litho machines)
- Assembly machines

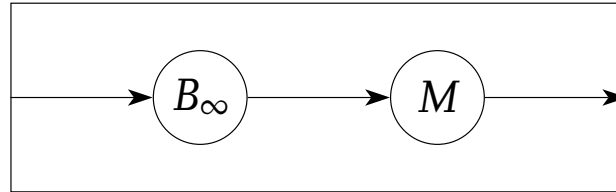
Type of models

- deterministic: mass conservation models
- stochastic: queueing models
- steady state
- transient: ODE (fluid models), PDE (flow models)

Examples:

- analytical: Kingman's equation
- numerical: process algebra
- enumeration: automata

Kingman's approximation for φ , 1961



$$\varphi = \left(\frac{c_a^2 + c_e^2}{2} \cdot \frac{u}{1-u} + 1 \right) \cdot t_e \quad u = \frac{t_e}{t_a}$$

φ mean flow time

c_a coefficient of variation of mean inter-arrival time t_a

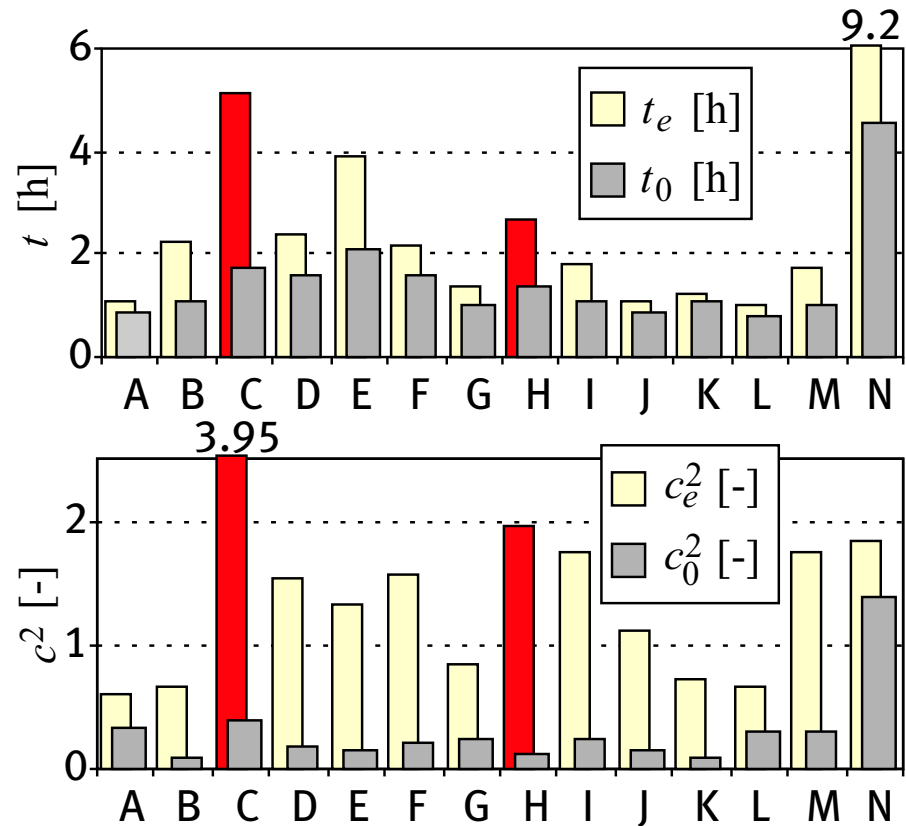
c_e coefficient of variation of mean effective process time t_e

u utilization

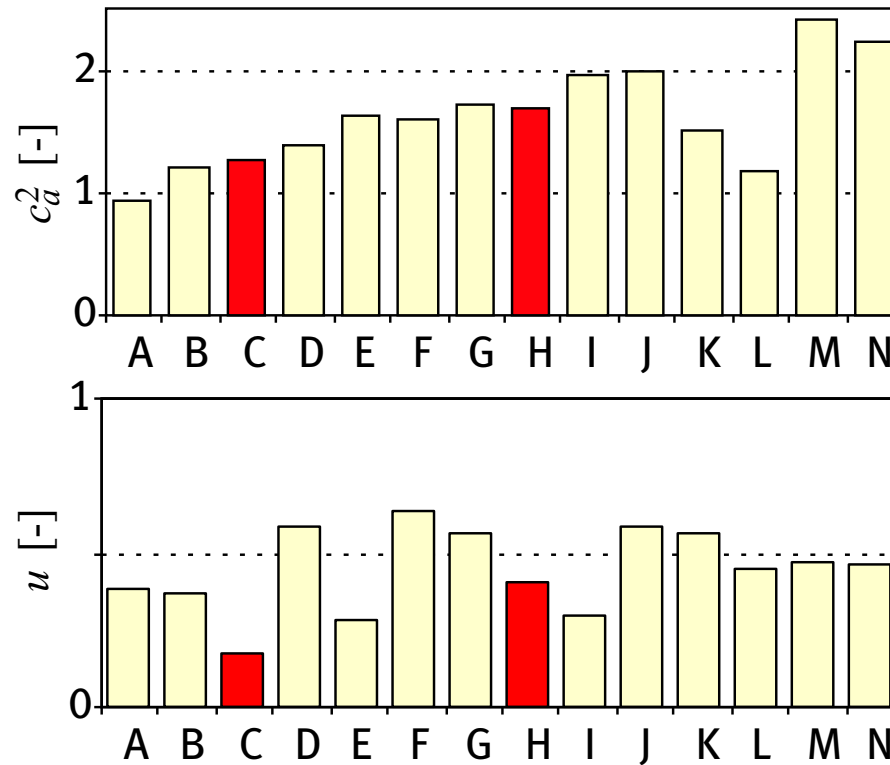
t_e mean effective process time

t_a mean inter-arrival time

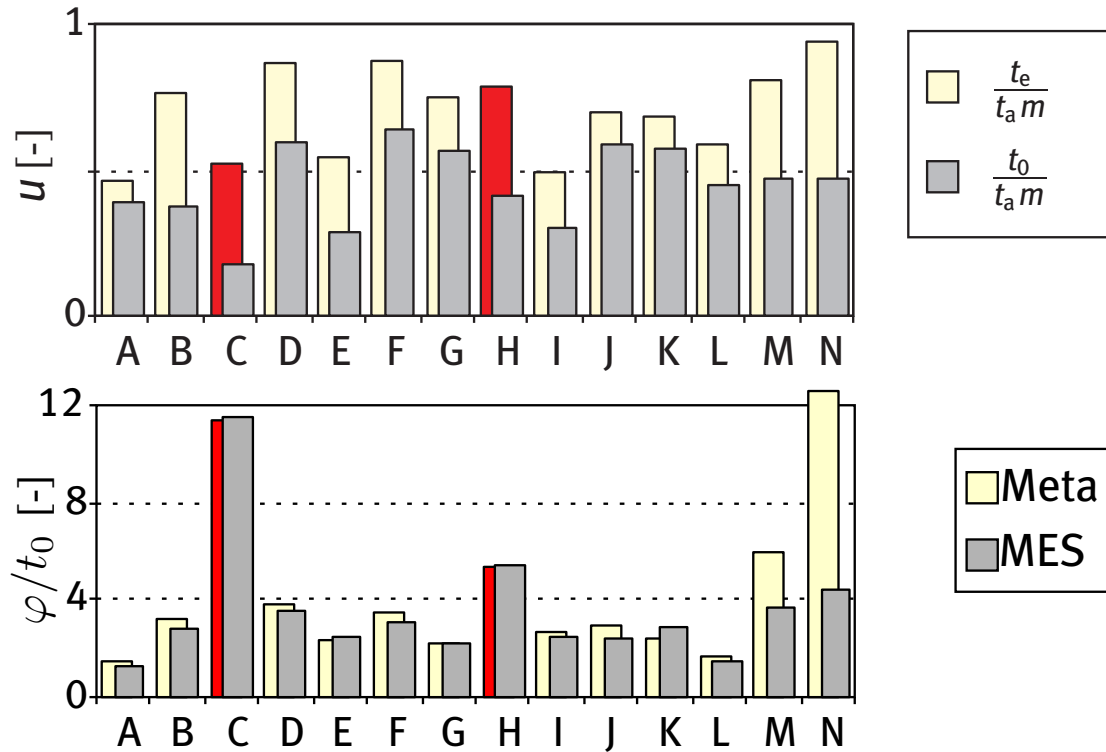
Case, Philips Nijmegen fabricator



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Process algebra

Informal definition

- A system contains components.
- The components execute concurrently (in parallel).
- The components interact via channels, which support various data types.

Motivation

- When a component is defined as a process algebra component we can use theory and tools to design and execute concurrent and interacting components, as well as to rewrite to other formalisms.

Atomic statements

$p_{\text{atom}} ::=$	skip	
	$\mathbf{x} := \mathbf{e}$	(multi-)assignment
	Δd	delay
	$h ! \mathbf{e}$	delayable send
	$h ? \mathbf{x}$	delayable receive
	$h !! \mathbf{e}$	send
	$h ?? \mathbf{x}$	receive

Compound statements

$p ::= p_{\text{atom}}$	atomic
$p; p$	sequential composition
$b \rightarrow p$	guard operator
$p \square p$	alternative composition
$p \parallel p$	parallel composition
$*p$	loop statement
$b \xrightarrow{*} p$	while statement
$\text{id}(e)$	process instantiation
$\llbracket \text{mode } X_1 = p_1$	mode definition
\vdots	
$, \text{mode } X_n = p_n$	
$:: X_i$	
\rrbracket	

Example, simple flow line

```
proc G(chan a! : real) =  
[[ var d : → real = exponential(4.0), x : real, t : real  
:: *( a!time; t := sample d; Δt )  
]]
```

```
proc B(chan a?, b! : real) =  
[[ var xs : [real] = [], x : real  
:: *( a?x; xs := xs ++[x]  
    [ len(xs) > 0 → b!hd(xs); xs := tl(xs)  
    )  
]]
```

```
proc M(chan a?, b! : real) =  
[[ var x : real :: *( a?x; Δ3.0; b!x )]]
```

```
proc E(chan a? : real) =  
[[ var x : real :: *( a?x; !!time, "\t", x, "\n" )]]
```

```
model GME() = [[ chan a, b, c : real :: G(a) || B(a, b) || M(b, c) || E(c) ]]
```

Example, some machines M

Break-down

```

proc M(chan a?, b!, l! : void) =
  [[ var tp, tf, tr : real
  :: [[ mode idle      = ( a ?; working )
      , mode working = ( Δtp; b!; idle
                        [] Δtf; l!; down
                        )
      , mode down     = ( Δtr; idle )
  :: idle
  ]]
  ]]
  ]]

```

Assembly

```

proc M(chan a?, b? : item, c! : (item, item)) =
  [[ var x, y : item :: *( ( a ? x || b ? y ); Δ3.0; c!(x, y) ) ] ]

```

Automata

Informal definition

- A system is described by the set of states, transitions between states, and actions (events) that occur when in a state or when transitioning between states.
- The system can only be in one of the states at a given time.
- Transitions may be conditioned by (external) variables.

Motivation

- When a component is defined as an automaton we can use theory and tools to derive a correct and optimal controller.

Automata

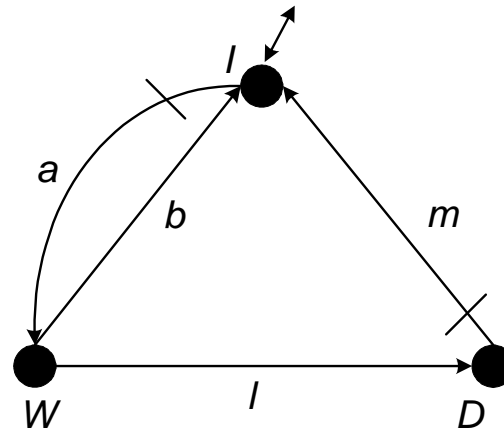
Automaton $A = (Q, \Sigma, \delta, q_0, Q_m)$ with

- Q – finite state set
- Σ – alphabet (finite set of event labels)
- δ – (partial) transition function, $\delta : Q \times \Sigma \rightarrow Q$
- q_0 – initial state
- Q_m – marker states, $Q_m \subseteq Q$

Supervisory control theory

- Σ_c – finite set of controllable event labels
- Σ_u – finite set of uncontrollable event labels
- partial observation
- ...

Example, machine with break-down

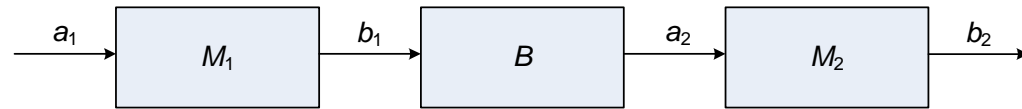


Automaton $M = (Q, \Sigma, \delta, q_0, Q_m)$ with

- $Q = \{I, W, D\}$ – State is Idle, Working or Down
- $\Sigma_c = \{a, m\}$ $\Sigma_u = \{b, l\}$
- $\delta: \delta(I, a) = W, \delta(D, m) = I, \delta(W, b) = I, \delta(W, l) = D$
- $q_0 = I$
- $Q_m = \{I\}$

Example, simple flow-line

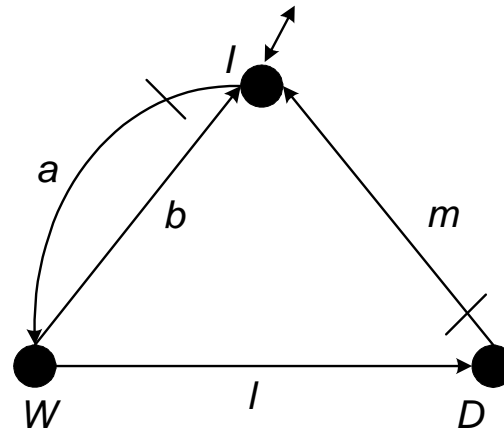
A manufacturing system consists of machine M_1 , a one-place buffer B , and machine M_2 , where both machines can break down.



Specifications

- Buffer B contains at most one product.
- When both machines break-down, M_2 must be repaired before M_1 .

Example, model of machine M_1



Operation

1. (initially empty) takes item from an infinite input bin and enters state $W(a_1)$, go to 2
2. then either breaks down, enters $D(l)$ and on repair returns to $I(m_1)$, or completes its work cycle, deposits the item in the buffer and returns to $I(b_1)$, go to 1

Example, models of buffer B and machine M_2

Operation B

1. (initially empty) tries to receive an item from M_1 , go to 2
2. tries to send an item to M_2 , go to 1

Operation M_2

- (initially empty) operates similarly as M_1 but it takes an item from buffer B and after completion deposits the item in an infinite bin

Example, goal of simple flow line

We now have:

- An automaton for M_1 .
- An automaton for B .
- An automaton for M_2 .

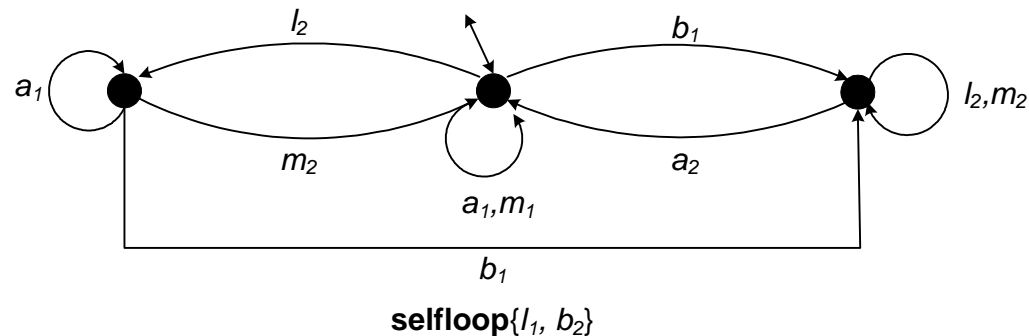
The goal is to derive a controller (supervisor automaton) that forces the system under control (flow-line) to satisfy its constraints (specifications).

Specifications

- Buffer B contains at most one product
- When both machines break-down, M_2 must be repaired before M_1 .

Example, simple flow-line supervisor

The trimmed, parallel composition of the machines and the buffer results in the automaton of the supervisor. This automaton contains all flow-line trajectories (evolutionary path) that are admissible with respect to the specifications.



Obtaining optimal performance means that these trajectories have to be evaluated according to some performance criterion.

Case

- Background
- Levels in systems
- Key performance ...
- Effective Process Time
- Type of models
- Queueing models
- Process algebra
- Automata
- Epilogue
- References

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Epilogue

Simulation

- only one trajectory is executed
- for stochastic models not a drawback

Verification

- all trajectories are investigated
- for deterministic models required

Epilogue

We use, e.g.:

- analytical approximation models,
- process algebra models, and
- automata

to analyze deterministic and stochastic system in a timed-discrete-event and hybrid setting.

The models are used for throughput and flow-time analysis in factories (e.g. automotive, semiconductor), areas (e.g. body-shop, litho), cells (e.g. track-scanner, cluster machines), and machines (litho scanners, MRI-scanners). Recently we applied our knowledge for the verification of supervisors in cells and machines.

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